

Docket No.: 4590-419

10/538057  
JC17 Rec'd PCT/PTO PATENT  
09 JUN 2005

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Didier QUIEVY

U.S. Patent Application No.: n/a

Filed: *herewith*

:  
:  
:  
:  
:  
:  
:

For: METHOD OF CALIBRATING A MICROWAVE SOURCE

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to examination of the above-referenced application, please amend the application as follows: